IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Alan T. Schachtely et al.

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For: METHODS AND SYSTEMS FOR

MONITORING AND DIAGNOSING

MACHINERY

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF

Commissioner for Patents

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Alexandria, VA 22313-1450

In response to the Office Action dated June 25, 2008, and made final, reconsideration of the rejection is respectfully requested in light of the following amendment and remarks.